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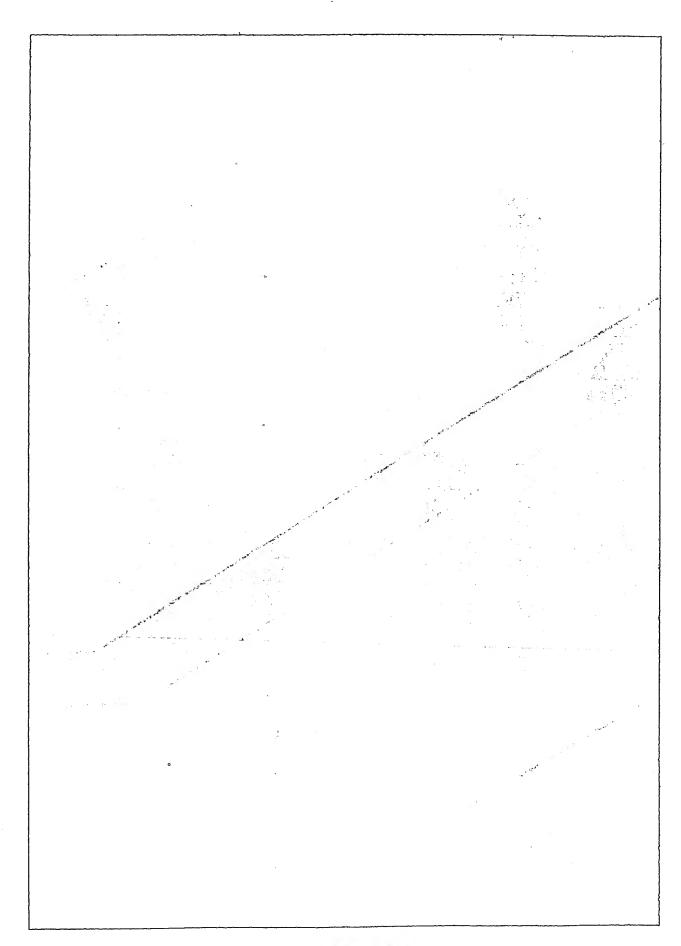
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Fig. IA

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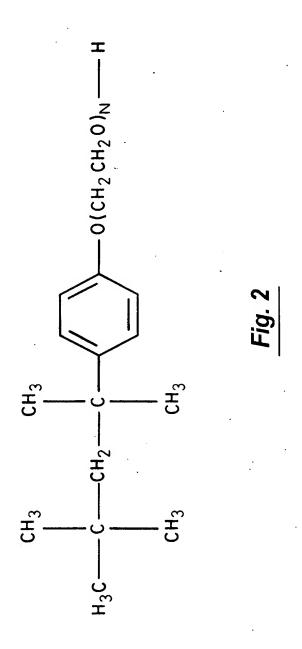
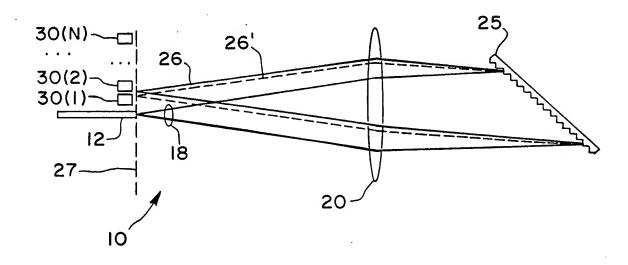
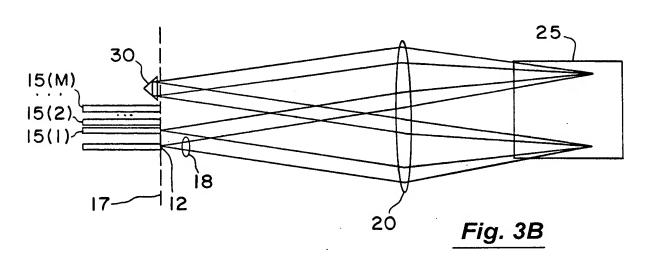
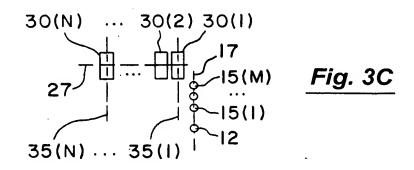
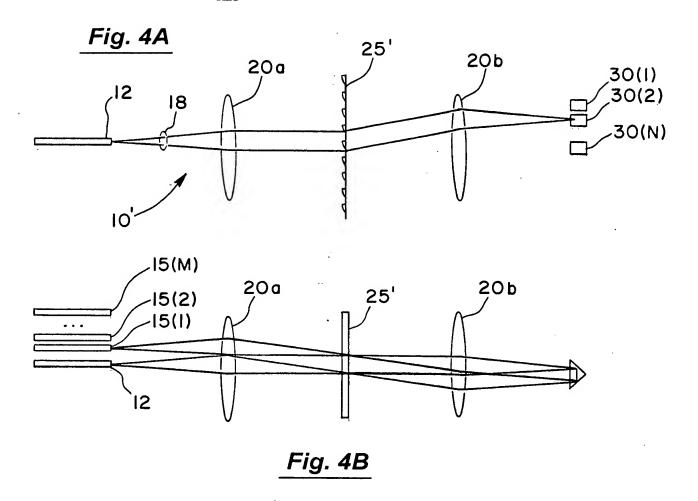


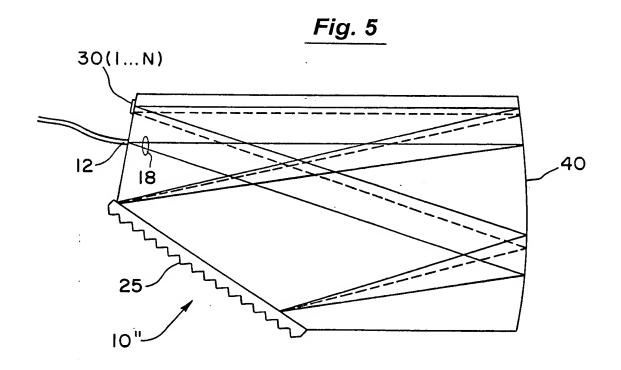
Fig. 3A











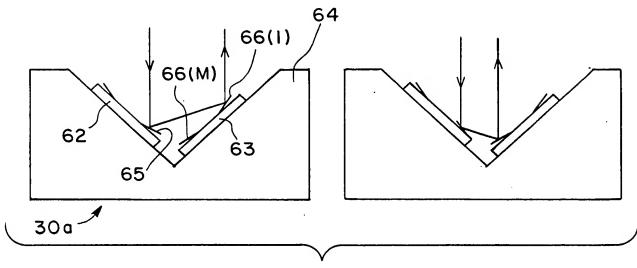


Fig. 6A

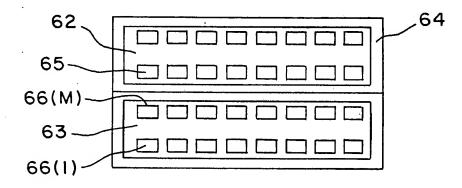


Fig. 6B

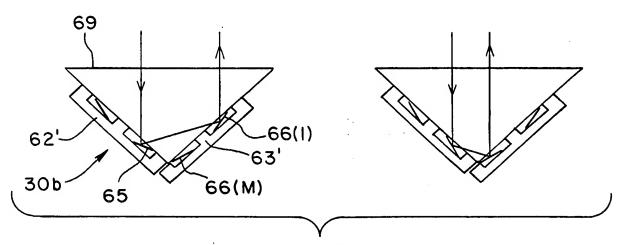
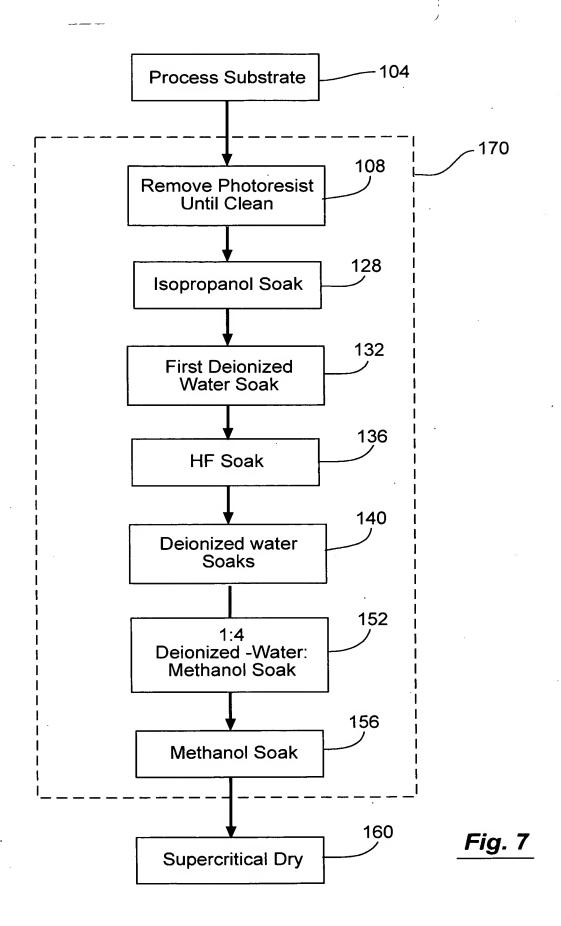


Fig. 6C



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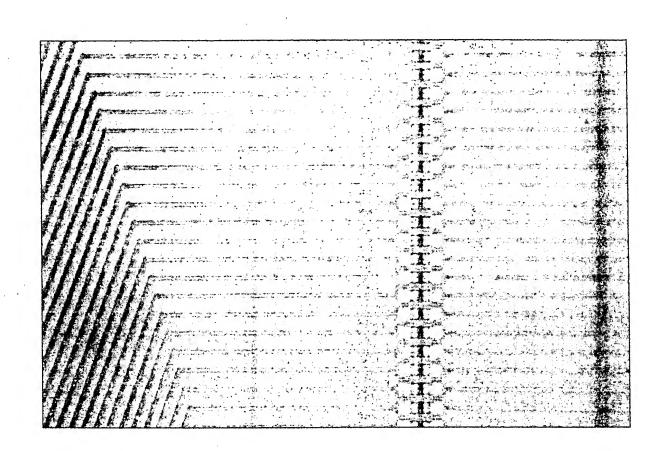


Fig. 8A

Fig. 8B

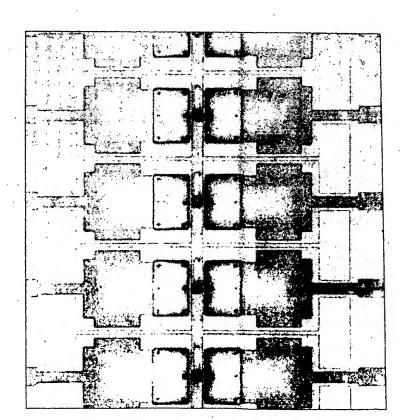


Fig.8C